

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Marc Laverdiere et al.

Serial No. : 10/520,635

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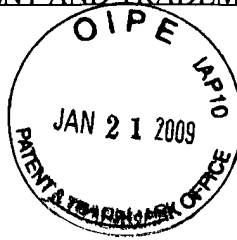
For : LIQUID FLOW CONTROLLER AND PRECISION DISPENSE APPARATUS
AND SYSTEM

Examiner : Lee, Kevin L.

Art Unit : 3753

Confirmation No: 5906

Attorney
Docket No. : 2002-29US



Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Sir:

INFORMATION DISCLOSURE STATEMENT

The Examiner is respectfully requested to consider the documents, which are listed on the attached form PTO 1449.


I hereby certify that each item of information contained in this information disclosure statement was first cited in any communication from the foreign office in a counterpart foreign application not more than three months prior to the filing of this statement. An English language version of the communication indicating the degree of relevance found by the foreign office is filed herewith.

US6,348,098 was previously cited in an Information Disclosure Statement filed in the above application on 3/10/05.


US5,983,926 corresponds to JP11-85287.

Copies of the non U.S. Patent listed on the attached form are enclosed herewith.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on **January 16, 2009**


Signature: **Kevin S. Lemack**
Date: **January 16, 2009**

Respectfully submitted,


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